

PATENT ASSIGNMENT

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CONVEYING PARTY DATA	
Name	Execution Date
Stanford University	11/09/2006
RECEIVING PARTY DATA	
Name:	National Science Foundation
Street Address:	4201 Wilson Blvd.
Internal Address:	rm 1265
City:	Arlington
State/Country:	VIRGINIA
Postal Code:	22230
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	11533719
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LICENSE TO THE UNITED STATES GOVERNMENT

Invention Title: **Propagating modes in subwavelength cylindrical holes in an optically thick metallic film**

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Patent or Application Serial No: 11/533,719

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Agency: **National Science Foundation**

Grant / Contract: **NSF 0134607**

Grantee / Contractor File: **S04-322**

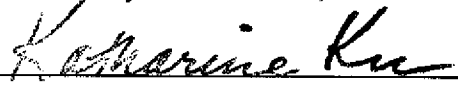
Foreign Applications:

The invention identified above is a Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14 of FAR 52.227-11, which are included among the terms of the above-identified grant/contract award from the above agency. This document is confirmatory of:

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The Government is hereby granted an irrevocable power to inspect and make copies of the above-identified patent application.

Signed this 9th day of November, 2006

By: 
Katharine Ku, Director, Office of Technology Licensing

For: The Board of Trustees of the Leland Stanford Junior University

At: Stanford University, Office of Technology Licensing, 1705 El Camino Real, Palo Alto, CA
94306-1106

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